IN THE UNITED STATES PATENT AND TRADEMARK OFFICE AY 2006

Applicant(s)

Terry L. Alford et al.

Application Serial Number

To be assigned May 9, 2006

Date of Filing Title

FLEXIBLE ELECTRONICS USING ION IMPLANTATION

TO ADHERE POLYMER SUBSTRATE TO SINGLE

CRYSTAL SILICON SUBSTRATE

Group Art Unit

To be assigned

Examiner

To be assigned

USPTO Customer No.

26707

Attorney Docket No.

112624.00062

INFORMATION DISCLOSURE STATEMENT PURSUANT TO 37 C.F.R. § 1.97

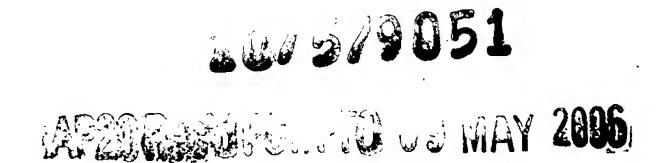
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Applicant hereby brings to the attention of the Examiner the documents noted on the accompanying Form PTO-1449. This Information Disclosure Statement is being filed prior to the mailing date of a first Office Action.

It is respectfully requested that the information cited herein be expressly considered during the prosecution of this application and made of record on any patent to issue therefrom. Inclusion of a reference on the enclosed Form PTO-1449 is not to be construed as indicating the reference is prior art with respect to the subject application. Submission of this Information Disclosure Statement is not to be taken as evidence that a search has been conducted.

Terry L. Alford *et al*.
Information Disclosure Statement



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Respectfully submitted,

By:_

QUARLES & BRADY STREICH LANG, LLP

May $\frac{Q}{1}$, 2006

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112624.00062

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	Application Number	To be assigned		
INFORMATION DISCLOSURE	Filing Date	May 9, 2006		
	First Named Inventor	Terry L. Alford		
STATEMENT BY APPLICANT	Art Unit	To be assigned		
(Use as many sheets as necessary)	Examiner Name	To be assigned		

Sheet

Attorney Docket Number

U. S. PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
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FOREIGN PATENT DOCUMENTS						
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Substitut	e for form 1449/P10			Application Number	To be assigned 2 / 9 1 5 1	
INFO	ORMATION	DIS	CLOSURE	Filing Date	May 9, 2006	
STATEMENT BY APPLICANT		First Named Inventor	Terry L. Alford			
				Art Unit	To be assigned	
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Sheet	2	of	2	Attorney Docket Number	112624.00062	

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	Α	Hochbauer et al., "Physical mechanisms behind the ion-cut in hydrogen implanted silicon", J. Appl. Phys., 92(5):2335-2342, 2002	
	В	Hochbauer et al., "Investigation of the cut location in hydrogen implantation induced silicon surface layer exfoliation", J. Appl. Phys., 89(11):5980-5990, 2001	
	С	Hochbauer et al., "Hydrogen blister in boron and hydrogen coimplanted n-type silicon", Appl. Phys. Lett., 75(25):3938-3940, 1999	
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